

Use of Automated Commissioning Simulations for Error Tolerance Evaluation for the APS-U

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2023-08-29 Workshop on Future Light Source 2023

APS-U – the nearest Future Light Source

- APS is in dark time now started April 2023
- The first light will be delivered in April 2024
	- Brightness increase factor: up to 500
- Installation progresses on schedule

General approach when considering tolerances

Static errors: How it was done for earlier machines

- Assume some distribution and magnitude of errors (alignment and/or manufacturing), calculate resulting machine distortions, limit distortions to reasonable values
	- Orbit and beta functions errors; could be done semi-analytically
- As focusing increased, orbit errors became too big required including orbit correction in assumptions
	- $\overline{}$ Included dynamic aperture in considerations, required simulations $^{\textrm{\tiny{1}}}$ with orbit correction
	- No lattice correction yet considered
- In early 2000s, lattice correction based on response matrix fit² became widely used but light sources designed at the time still didn't consider lattice correction in tolerance calculations
	- $\overline{}$ Some designs even included remote girder movers 3 to improve girder alignment postconstruction to improve accelerator performance
	- Tolerances were likely overspecified

¹E. Crosbie, et. al., 1993 PAC Proc.

²J. Safranek, NIM A 388, 27 (1997) 3S. Zelenika et al., NIM A 467-468, 2001

Typical pre-MBA workflow for error effect evaluation

- Generate error ensembles
- Correct closed orbit
- **Correct lattice**
- Calculate expected injection efficiency (or DA) and lifetime (or MA)
- Repeat 100s times, calculate statistics
- Limit amplitudes of error distributions to those that provide acceptable performance
- For simplicity, one can isolate a single kind of error and treat its effect separately
- Example of isolated treatment: tolerance on longitudinal quad alignment
	- Use ideal lattice, add longitudinal quad misalignment with Gaussian distribution
	- Calculate resulting beta function errors
	- $-$ Limit median rms beta functions errors to 1%, obtain requirement for quad misalignment
		- Resulted in 70 µm rms for APS-U

Old approach did not work for new rings

- Evaluated hundreds of APS-U error sets no closed orbit exists for reasonable error sets in 100% of cases
- Repeated the same study for different fractions of the nominal error set
- To ensure closed orbit existence, one needs to reduce errors by a factor of 5-10 – unrealistic!

APS-U alignment and strength errors (rms, 2σ cutoff)

Percentage of error ensembles with existing closed orbit as a function of a fraction of the nominal error set

Commissioning simulation is the new way to evaluate errors

- Two ways to get around the orbit existence problem
	- Ramping of errors
		- Straightforward ramping while correcting orbit with reasonable ramping steps didn't work
		- Required extra thinking
	- Simulation of "real" machine commissioning
		- Start with trajectory correction and go forward as we would do for real commissioning
		- More complicated that ramping
		- In addition, allows to study actual commissioning strategies

Commissioning simulation is made as realistic as possible1,2,3

- Procedure is based on multi-particle bunch tracking and consists of the following steps:
	- Error generation alignment, strengths, multipoles, injection, etc.
	- First-turn correction with zero sextupoles
	- Global trajectory correction
	- Beam-based alignment
	- Sextupole ramping while performing correction of pseudo-orbit (multi-turn trajectory averaged on each BPM)
		- Betatron tune and RF adjustments
		- Results in beam capture
	- Orbit correction
	- Beta functions and coupling correction using response matrix fit
	- Calculate DA/MA or injection efficiency and lifetime
- Single run requires about 2-3 days to complete on a single core
	- Hundreds of runs are essential to generate statistics
- Blue color shows steps not needed if one only wanted to evaluate tolerances quasicommissioning

¹V. Sajaev, PRAB 22, 040102 (2019) ²T. Hellert et al., PRAB 22, 100702 (2019) 3T. Hellert et al., PRAB 25, 110701 (2022)

Commissioning simulations allow to evaluate many effects

- Commissioning simulations are complex, but allow for evaluation of many errors:
	- Misalignment, magnet strength errors, and high-order multipoles
	- Injection errors, injected beam parameters
	- BPM offset/noise
	- Realistic aperture
- Due to many dimensions, hard to perform scans

Alignment and strength errors (rms, 2σ cutoff)

BPM/corrector errors (rms)

Typical APS-U workflow

Use examples

- For every request, we re-run commissioning simulations and analyze statistics
- Design step:
	- Switch from support design using 3 large girders to 3 smaller girders + 2 mini-girders confirmed that performance is comparable
- Acceptance step:
	- $-$ 2 quad families and 1 focusing dipole family came with non-zero average tilts and tilt errors exceeding twice the requirements – performance was found to be acceptable
	- 2 sextupoles came with 12 mrad and 4 mrad tilts (requirement is 0.4 mrad) accepted
	- Longitudinal alignment of one magnet family on girders was exceeding tolerance by a factor of two – relaxed the requirements by a factor of 4

Lattice evaluation could relax requirements a lot

- Longitudinal alignment tolerance: initial simplified tolerance determination
	- Final accuracy of beta function correction after commissioning is 2-3% rms (without longitudinal misalignment)
	- Allow for 1% rms beta function distortion from longitudinal misalignment only
	- Results in 70 μm rms alignment tolerance (on-girder placement)
- To relax, ran commissioning simulations
	- Results showed that even 1 mm rms was acceptable
	- Relaxed requirements to 250 μm rms

ID vacuum chamber misalignment tolerance¹

- Concern: lifetime and/or particle loss distribution can change significantly
- Added ID chamber misalignment to commissioned ensembles, evaluated DA, lifetime, and losses
	- Based on DA and lifetime only, 300 μm would be acceptable
	- However, losses at IDs increase significantly above 75 μm

¹Courtesy M. Borland

Effect of increased M3 yaw

- Production M3 magnet family was determined to have possible yaw errors of up to 0.5 mrad
- Full commissioning simulation was run with increased M3 yaw errors
- Effect on DA is rather small, but 20% reduction of the minimum lifetime is a concern

Performance with actual measured magnets

- Performance evaluation was performed using magnetic measurements (multipoles and tilts) of 80% of production magnets
- Additionally, M3 family had slightly larger than spec tilts, tested if reduction would be beneficial
- Very small reduction of DA with measured multipoles/tilts, lifetime effect is also very small
- Reduction of M3 tilts does not provide any improvements

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Summary

- Various ways exist to calculate effect of errors on the machine performance if one considers error types separately or combines a few types of errors
	- Typically requires careful choice of assumptions or proxies for lifetime/injection
	- Different error types may require different approaches
	- Hard to consider effect on commissioning
- If one wants to consider many errors together – commissioning simulations are the best way
	- Allow to see effect of any type of errors on the accelerator performance
	- Give answer in terms of actual machine performance (injection, lifetime)
	- Do not rely on initial existence of closed orbit
	- Same simulations for all types of errors
	- Too many variables hard to do error amplitude scans
- Commissioning simulations can be used for acceptance of production items
- Automation of the entire commissioning process is essential

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